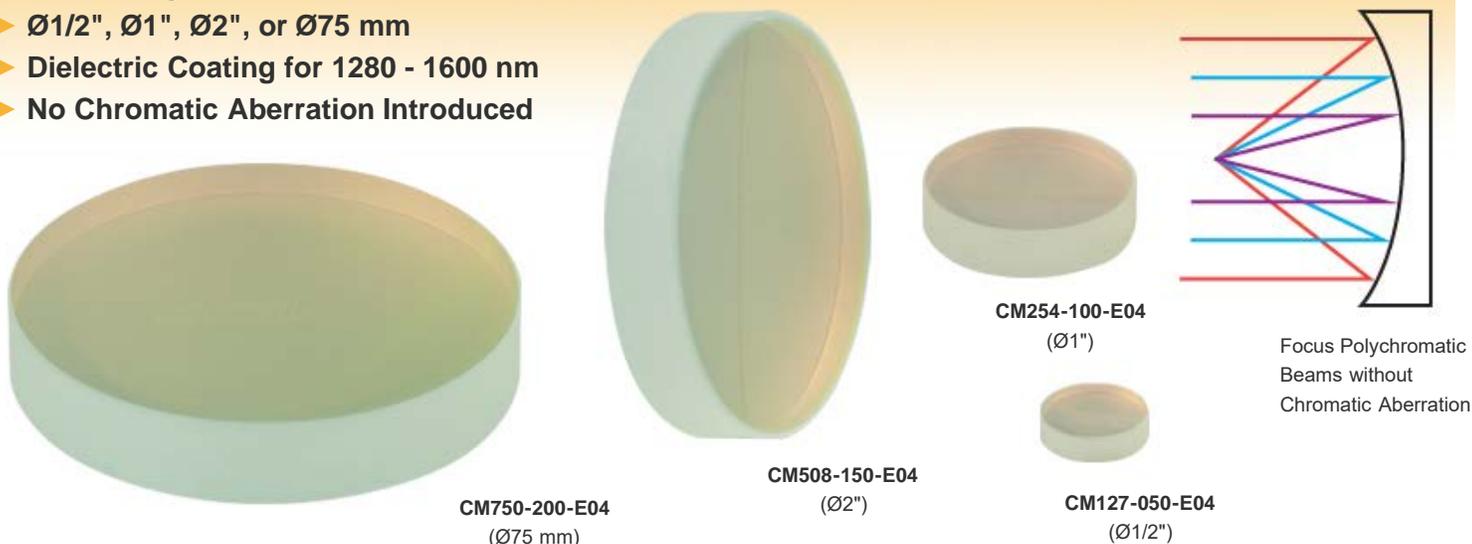


CM750-200-E04 - June 15, 2018

Item # CM750-200-E04 was discontinued on June 15, 2018. For informational purposes, this is a copy of the website content at that time and is valid only for the stated product.

CONCAVE MIRRORS: IR DIELECTRIC COATING (1280 - 1600 NM)

- ▶ Focal Lengths from 12 - 200 mm
- ▶ Ø1/2", Ø1", Ø2", or Ø75 mm
- ▶ Dielectric Coating for 1280 - 1600 nm
- ▶ No Chromatic Aberration Introduced



OVERVIEW

Dielectric Concave Mirrors Selection Guide	
UV (350 - 400 nm)	VIS (400 - 750 nm)
NIR (750 - 1100 nm)	Telecom (1280 - 1600 nm)

See the *Concave Mirror Guide* tab, above, for our complete selection of concave mirrors.

Features

- Dielectric Coating Range; 1280 - 1600 nm (-E04)
- >99% Average Reflectivity in Dielectric Coating Range
- Four Diameter Options: 1/2", 1", 2", or 75 mm
- Focal Lengths Range from 9.5 mm - 200 mm

Thorlabs' Broadband Dielectric Concave Mirrors are designed for light collection, imaging, and focusing applications. These reflective optics focus light without introducing chromatic aberration, making them especially suitable for broadband sources.

All of the mirrors on this page can be mounted by our Precision Kinematic Mirror Mounts.

Common Specifications	
Available Diameters	1/2", 1", 2", and 75 mm
Dielectric Coating Range	1280 - 1600 nm; $R_{avg} >99\%$
Clear Aperture	>90% of Diameter
Surface Irregularity	$\lambda/4 @ 633 \text{ nm}$
Surface Quality	20-10 Scratch-Dig
Diameter Tolerance	+0.0/-0.2 mm
Thickness Tolerance	$\pm 0.2 \text{ mm}$
Substrate	N-BK7 ^a
Backside Surface	Fine Ground and Engraved with Part Number (Not Polished)
Damage Threshold	Pulse (1542 nm, 10 ns, 10 Hz, Ø0.181 mm)
	CW ^b (1540 nm, Ø1.030 mm)

- [Click Link](#) for Detailed Specifications on the Substrate
- [Refer](#) to the *Damage Thresholds* Tab for Details

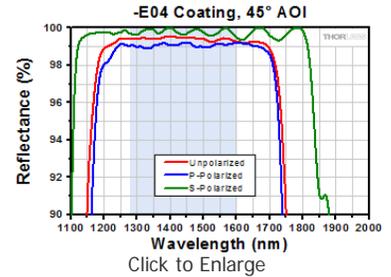
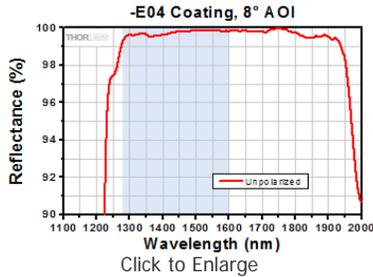
Thorlabs also offers metallic concave mirrors that operate over a broader wavelength range at the expense of lower reflectivity. Please contact Tech Support

for custom versions of these optics.



GRAPHS

These plots show the reflectivity of our -E04 dielectric coating for a typical coating run. The shaded region in each graph denotes the spectral range over which the coating is highly reflective. Due to variations in each run, this recommended spectral range is narrower than the actual range over which the optic will be highly reflective. If you have any concerns about the interpretation of this data, please contact Tech Support. For applications that require a mirror that bridges the spectral range between two dielectric coatings, please consider a metallic concave mirror.



Excel Spreadsheet with Raw Data for -E04 Coating, 8° and 45° AOI

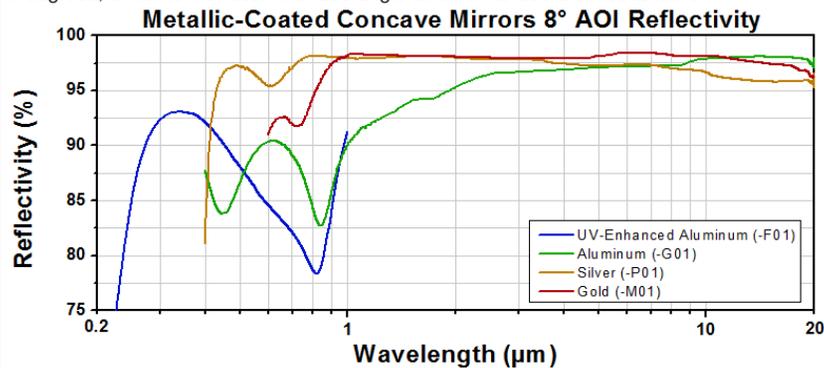
CONCAVE MIRROR GUIDE

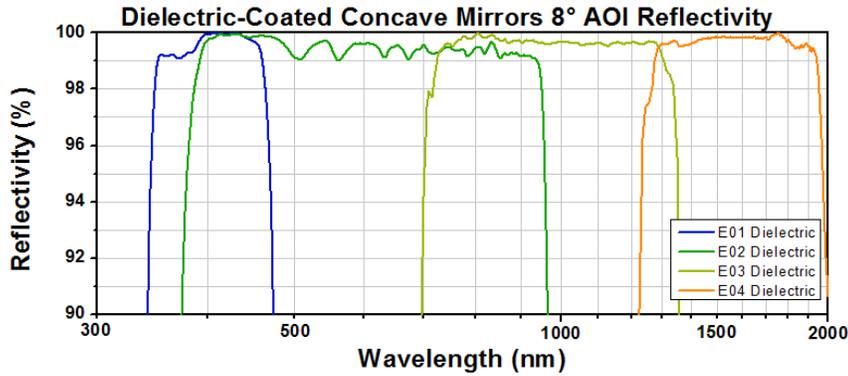
Concave Mirror Selection Guide

Thorlabs offers concave mirrors with both metallic and dielectric stack reflective coatings. Metallic-coated mirrors offer relatively high reflectivity (90-95%) over a wide wavelength range, while dielectric-coated mirrors provide even higher reflectivity (>99%) but over a smaller wavelength range. See the table to the right for an overview of the various coatings we offer for our concave mirrors. All coating options are available on optics with diameters ranging from Ø1/2" to Ø75 mm. Metallic mirrors are available with focal lengths from 9.5 - 500 mm, while dielectric mirrors are available with focal lengths from 12 - 500 mm.

Below are reflectivity plots for our complete line of concave mirrors. To view our selection of mirrors available with a particular coating, either click on the graphed line of interest or the corresponding coating name in the legend. Graphs are shown for an angle of incidence (AOI) of 8 degrees, which is the recommended angle at which to use a concave mirror.

Concave Mirrors Coating Options	
Coating	Wavelength Range
UV Enhanced Aluminum	250 - 450 nm
Aluminum	450 nm - 20 µm
Silver	450 nm - 20 µm
Gold	800 nm - 20 µm
E01 Dielectric	350 - 400 nm
E02 Dielectric	400 - 750 nm
E03 Dielectric	750 - 1100 nm
E04 Dielectric	1280 - 1600 nm





Click on a particular graphed line or the corresponding name in the legend to view concave mirrors with that coating option.

DAMAGE THRESHOLDS

Damage Threshold Data for Thorlabs' Telecom Dielectric Mirrors

The specifications to the right are measured data for Thorlabs' -E04 coated dielectric mirrors. Damage threshold specifications are constant for all -E04 coated dielectric mirrors, regardless of the size or focal length of the mirror.

Damage Threshold Specifications		
Coating Designation (Item # Suffix)	Damage Threshold	
-E04	Pulse	2.5 J/cm ² (1542 nm, 10 ns, 10 Hz, Ø0.181 mm)
	CW ^{a,b}	>1.52 kW/cm (1540 nm, Ø1.030 mm)

- ~~a~~ The power density of your beam should be calculated in terms of W/cm. For an explanation of why the linear power density provides the best metric for long pulse and CW sources, please see the "Continuous Wave and Long-Pulse Lasers" section below.
- ~~b~~ The stated damage threshold is a certification measurement, as opposed to a true damage threshold (i.e., the optic was able to withstand the maximum output of the laser with no damage).

Laser Induced Damage Threshold Tutorial

The following is a general overview of how laser induced damage thresholds are measured and how the values may be utilized in determining the appropriateness of an optic for a given application. When choosing optics, it is important to understand the Laser Induced Damage Threshold (LIDT) of the optics being used. The LIDT for an optic greatly depends on the type of laser you are using. Continuous wave (CW) lasers typically cause damage from thermal effects (absorption either in the coating or in the substrate). Pulsed lasers, on the other hand, often strip electrons from the lattice structure of an optic before causing thermal damage. Note that the guideline presented here assumes room temperature operation and optics in new condition (i.e., within scratch-dig spec, surface free of contamination, etc.). Because dust or other particles on the surface of an optic can cause damage at lower thresholds, we recommend keeping surfaces clean and free of debris. For more information on cleaning optics, please see our *Optics Cleaning* tutorial.

Testing Method

Thorlabs' LIDT testing is done in compliance with ISO/DIS11254 and ISO 21254 specifications.

First, a low-power/energy beam is directed to the optic under test. The optic is exposed in 10 locations to this laser beam for 30 seconds (CW) or for a number of pulses (pulse repetition frequency specified). After exposure, the optic is examined by a microscope (~100X magnification) for any visible damage. The number of locations that are damaged at a particular power/energy level is recorded. Next, the power/energy is either increased or decreased and the optic is exposed at 10 new locations. This process is repeated until damage is observed. The damage threshold is then assigned to be the highest power/energy that the optic can withstand without causing damage. A histogram such as that below represents the testing of one BB1-E02 mirror.



The photograph above is a protected aluminum-coated mirror after LIDT testing. In this particular test, it handled 0.43 J/cm^2 (1064 nm, 10 ns pulse, 10 Hz, $\text{Ø}1.000 \text{ mm}$) before damage.

According to the test, the damage threshold of the mirror was 2.00 J/cm^2 (532 nm, 10 ns pulse, 10 Hz, $\text{Ø}0.803 \text{ mm}$). Please keep in mind that these tests are performed on clean optics, as dirt and contamination can significantly lower the damage threshold of a component. While the test results are only representative of one coating run, Thorlabs specifies damage threshold values that account for coating variances.

Continuous Wave and Long-Pulse Lasers

When an optic is damaged by a continuous wave (CW) laser, it is usually due to the melting of the surface as a result of absorbing the laser's energy or damage to the optical coating (antireflection) [1]. Pulsed lasers with pulse lengths longer than $1 \mu\text{s}$ can be treated as CW lasers for LIDT discussions.

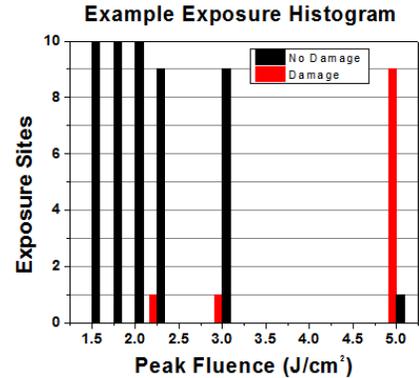
When pulse lengths are between 1 ns and $1 \mu\text{s}$, laser-induced damage can occur either because of absorption or a dielectric breakdown (therefore, a user must check both CW and pulsed LIDT). Absorption is either due to an intrinsic property of the optic or due to surface irregularities; thus LIDT values are only valid for optics meeting or exceeding the surface quality specifications given by a manufacturer. While many optics can handle high power CW lasers, cemented (e.g., achromatic doublets) or highly absorptive (e.g., ND filters) optics tend to have lower CW damage thresholds. These lower thresholds are due to absorption or scattering in the cement or metal coating.

Pulsed lasers with high pulse repetition frequencies (PRF) may behave similarly to CW beams. Unfortunately, this is highly dependent on factors such as absorption and thermal diffusivity, so there is no reliable method for determining when a high PRF laser will damage an optic due to thermal effects. For beams with a high PRF both the average and peak powers must be compared to the equivalent CW power. Additionally, for highly transparent materials, there is little to no drop in the LIDT with increasing PRF.

In order to use the specified CW damage threshold of an optic, it is necessary to know the following:

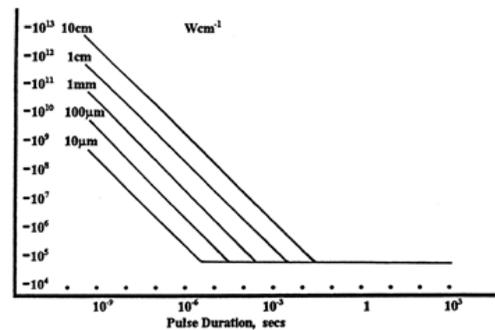
1. Wavelength of your laser
2. Beam diameter of your beam ($1/e^2$)
3. Approximate intensity profile of your beam (e.g., Gaussian)
4. Linear power density of your beam (total power divided by $1/e^2$ beam diameter)

Thorlabs expresses LIDT for CW lasers as a linear power density measured in W/cm. In this regime, the LIDT given as a linear power density can be applied to any beam diameter; one does not need to compute an adjusted LIDT to adjust for changes in spot size, as demonstrated by the graph to the right. Average linear power density can be calculated using the equation below.



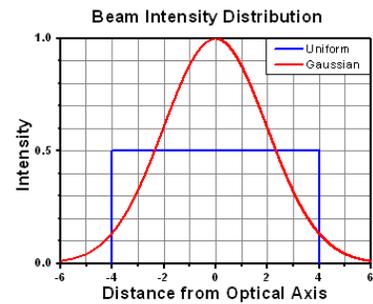
Example Test Data

Fluence	# of Tested Locations	Locations with Damage	Locations Without Damage
1.50 J/cm^2	10	0	10
1.75 J/cm^2	10	0	10
2.00 J/cm^2	10	0	10
2.25 J/cm^2	10	1	9
3.00 J/cm^2	10	1	9
5.00 J/cm^2	10	9	1



LIDT in linear power density vs. pulse length and spot size. For long pulses to CW, linear power density becomes a constant with spot size. This graph was obtained from [1].

$$\text{Linear Power Density} = \frac{\text{Power}}{\text{Beam Diameter}}$$



The calculation above assumes a uniform beam intensity profile. You must now consider hotspots in the beam or other non-uniform intensity profiles and roughly calculate a maximum power density. For reference, a Gaussian beam typically has a maximum power density that is twice that of the uniform beam (see lower right).

Now compare the maximum power density to that which is specified as the LIDT for the optic. If the optic was tested at a wavelength other than your operating wavelength, the damage threshold must be scaled appropriately. A good rule of thumb is that the damage threshold has a linear relationship with wavelength such that as you move to shorter wavelengths, the damage threshold decreases (i.e., a LIDT of 10 W/cm at 1310 nm scales to 5 W/cm at 655 nm):

$$\text{Adjusted LIDT} = \text{LIDT Power} \left(\frac{\text{Your Wavelength}}{\text{LIDT Wavelength}} \right)$$

While this rule of thumb provides a general trend, it is not a quantitative analysis of LIDT vs wavelength. In CW applications, for instance, damage scales more strongly with absorption in the coating and substrate, which does not necessarily scale well with wavelength. While the above procedure provides a good rule of thumb for LIDT values, please contact Tech Support if your wavelength is different from the specified LIDT wavelength. If your power density is less than the adjusted LIDT of the optic, then the optic should work for your application.

Please note that we have a buffer built in between the specified damage thresholds online and the tests which we have done, which accommodates variation between batches. Upon request, we can provide individual test information and a testing certificate. The damage analysis will be carried out on a similar optic (customer's optic will not be damaged). Testing may result in additional costs or lead times. Contact Tech Support for more information.

Pulsed Lasers

As previously stated, pulsed lasers typically induce a different type of damage to the optic than CW lasers. Pulsed lasers often do not heat the optic enough to damage it; instead, pulsed lasers produce strong electric fields capable of inducing dielectric breakdown in the material. Unfortunately, it can be very difficult to compare the LIDT specification of an optic to your laser. There are multiple regimes in which a pulsed laser can damage an optic and this is based on the laser's pulse length. The highlighted columns in the table below outline the relevant pulse lengths for our specified LIDT values.

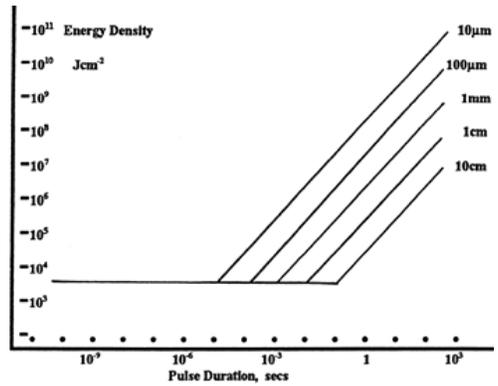
Pulses shorter than 10^{-9} s cannot be compared to our specified LIDT values with much reliability. In this ultra-short-pulse regime various mechanics, such as multiphoton-avalanche ionization, take over as the predominate damage mechanism [2]. In contrast, pulses between 10^{-7} s and 10^{-4} s may cause damage to an optic either because of dielectric breakdown or thermal effects. This means that both CW and pulsed damage thresholds must be compared to the laser beam to determine whether the optic is suitable for your application.

Pulse Duration	$t < 10^{-9}$ s	$10^{-9} < t < 10^{-7}$ s	$10^{-7} < t < 10^{-4}$ s	$t > 10^{-4}$ s
Damage Mechanism	Avalanche Ionization	Dielectric Breakdown	Dielectric Breakdown or Thermal	Thermal
Relevant Damage Specification	No Comparison (See Above)	Pulsed	Pulsed and CW	CW

When comparing an LIDT specified for a pulsed laser to your laser, it is essential to know the following:

1. Wavelength of your laser
2. Energy density of your beam (total energy divided by $1/e^2$ area)
3. Pulse length of your laser
4. Pulse repetition frequency (prf) of your laser
5. Beam diameter of your laser ($1/e^2$)
6. Approximate intensity profile of your beam (e.g., Gaussian)

The energy density of your beam should be calculated in terms of J/cm^2 . The graph to the right shows why expressing the LIDT as an energy density provides the best metric for short pulse sources. In this regime, the LIDT given as an energy density can be applied to any beam diameter; one does not need to compute an adjusted LIDT to adjust for changes in spot size. This calculation assumes a uniform beam



intensity profile. You must now adjust this energy density to account for hotspots or other nonuniform intensity profiles and roughly calculate a maximum energy density. For reference a Gaussian beam typically has a maximum energy density that is twice that of the $1/e^2$ beam.

LIDT in energy density vs. pulse length and spot size. For short pulses, energy density becomes a constant with spot size. This graph was obtained from [1].

Now compare the maximum energy density to that which is specified as the LIDT for the optic. If the optic was tested at a wavelength other than your operating wavelength, the damage threshold must be scaled appropriately [3]. A good rule of thumb is that the damage threshold has an inverse square root relationship with wavelength such that as you move to shorter wavelengths, the damage threshold decreases (i.e., a LIDT of 1 J/cm² at 1064 nm scales to 0.7 J/cm² at 532 nm):

$$\text{Adjusted LIDT} = \text{LIDT Energy} \sqrt{\frac{\text{Your Wavelength}}{\text{LIDT Wavelength}}}$$

You now have a wavelength-adjusted energy density, which you will use in the following step.

Beam diameter is also important to know when comparing damage thresholds. While the LIDT, when expressed in units of J/cm², scales independently of spot size; large beam sizes are more likely to illuminate a larger number of defects which can lead to greater variances in the LIDT [4]. For data presented here, a <1 mm beam size was used to measure the LIDT. For beams sizes greater than 5 mm, the LIDT (J/cm²) will not scale independently of beam diameter due to the larger size beam exposing more defects.

The pulse length must now be compensated for. The longer the pulse duration, the more energy the optic can handle. For pulse widths between 1 - 100 ns, an approximation is as follows:

$$\text{Adjusted LIDT} = \text{LIDT Energy} \sqrt{\frac{\text{Your Pulse Length}}{\text{LIDT Pulse Length}}}$$

Use this formula to calculate the Adjusted LIDT for an optic based on your pulse length. If your maximum energy density is less than this adjusted LIDT maximum energy density, then the optic should be suitable for your application. Keep in mind that this calculation is only used for pulses between 10⁻⁹ s and 10⁻⁷ s. For pulses between 10⁻⁷ s and 10⁻⁴ s, the CW LIDT must also be checked before deeming the optic appropriate for your application.

Please note that we have a buffer built in between the specified damage thresholds online and the tests which we have done, which accommodates variation between batches. Upon request, we can provide individual test information and a testing certificate. Contact Tech Support for more information.

- [1] R. M. Wood, *Optics and Laser Tech.* **29**, 517 (1998).
 [2] Roger M. Wood, *Laser-Induced Damage of Optical Materials* (Institute of Physics Publishing, Philadelphia, PA, 2003).
 [3] C. W. Carr *et al.*, *Phys. Rev. Lett.* **91**, 127402 (2003).
 [4] N. Bloembergen, *Appl. Opt.* **12**, 661 (1973).

Å

Ø1/2" (12.7 mm) Broadband Dielectric Concave Mirrors (1280 - 1600 nm)

Item #	Focal Length	Center Thickness	Edge Thickness	Radius of Curvature	Reference Drawing
CM127-012-E04	12 mm		3.8 mm	24.0 mm (0.94")	

CM127-025-E04	25 mm	3.0 mm	3.4 mm	50.0 mm (1.97")	
CM127-050-E04	50 mm		3.2 mm	100.0 mm (3.94")	

Part Number	Description	Price	Availability
CM127-012-E04	Ø1/2" Dielectric-Coated Concave Mirror, 1280 - 1600 nm, f = 12 mm	\$87.47	Today
CM127-025-E04	Ø1/2" Dielectric-Coated Concave Mirror, 1280 - 1600 nm, f = 25 mm	\$87.47	Today
CM127-050-E04	Ø1/2" Dielectric-Coated Concave Mirror, 1280 - 1600 nm, f = 50 mm	\$87.47	Today

Ø1" (25.4 mm) Broadband Dielectric Concave Mirrors (1280 - 1600 nm)

Item #	Focal Length	Center Thickness	Edge Thickness	Radius of Curvature	Reference Drawing
CM254-025-E04	25 mm	6.0 mm	7.6 mm	50.0 mm (1.97")	
CM254-050-E04	50 mm		6.8 mm	100.0 mm (3.94")	
CM254-075-E04	75 mm		6.5 mm	150.0 mm (5.91")	
CM254-100-E04	100 mm		6.4 mm	200.0 mm (7.87")	

Part Number	Description	Price	Availability
CM254-025-E04	Ø1" Dielectric-Coated Concave Mirror, 1280 - 1600 nm, f = 25 mm	\$112.20	Today
CM254-050-E04	Ø1" Dielectric-Coated Concave Mirror, 1280 - 1600 nm, f = 50 mm	\$112.20	Today
CM254-075-E04	Ø1" Dielectric-Coated Concave Mirror, 1280 - 1600 nm, f = 75 mm	\$112.20	Today
CM254-100-E04	Ø1" Dielectric-Coated Concave Mirror, 1280 - 1600 nm, f = 100 mm	\$112.20	Today

Ø2" (50.8 mm) Broadband Dielectric Concave Mirrors (1280 - 1600 nm)

Item #	Focal Length	Center Thickness	Edge Thickness	Radius of Curvature	Reference Drawing
CM508-050-E04	50 mm	9.0 mm	12.2 mm	100.0 mm (3.94")	
CM508-100-E04	100 mm		10.6 mm	200.0 mm (7.87")	
CM508-150-E04	150 mm		10.1 mm	300.0 mm (11.81")	
CM508-200-E04	200 mm		9.8 mm	400.0 mm (15.75")	

Part Number	Description	Price	Availability
CM508-050-E04	Ø2" Dielectric-Coated Concave Mirror, 1280 - 1600 nm, f = 50 mm	\$171.36	Today
CM508-100-E04	Ø2" Dielectric-Coated Concave Mirror, 1280 - 1600 nm, f = 100 mm	\$171.36	Today
CM508-150-E04	Ø2" Dielectric-Coated Concave Mirror, 1280 - 1600 nm, f = 150 mm	\$171.36	Today
CM508-200-E04	Ø2" Dielectric-Coated Concave Mirror, 1280 - 1600 nm, f = 200 mm	\$171.36	Today

Ø75 mm Broadband Dielectric Concave Mirrors (1280 - 1600 nm)

Item #	Focal Length	Center Thickness	Edge Thickness	Radius of Curvature	Reference Drawing
CM750-075-E04	75 mm	12.0 mm	16.7 mm	150.0 mm (5.91")	
CM750-150-E04	150 mm		14.3 mm	300.0 mm (11.81")	
CM750-200-E04	200 mm		13.7 mm	400.0 mm (15.75")	

These items will be retired without replacement when stock is depleted. If you require one of these parts for line production, please contact our OEM Team.

Limited STOCK

Part Number	Description	Price	Availability
CM750-075-E04	Ø75 mm Dielectric-Coated Concave Mirror, 1280 - 1600 nm, f = 75 mm	\$107.10	Today
CM750-150-E04	Ø75 mm Dielectric-Coated Concave Mirror, 1280 - 1600 nm, f = 150 mm	\$107.10	Today
CM750-200-E04	Ø75 mm Dielectric-Coated Concave Mirror, 1280 - 1600 nm, f = 200 mm	\$108.12	Lead Time